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GEMOLOGICAL
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LABORATORY GROWN DIAMOND REPORT

November 22, 2025

IGI Report Number **LG750539760**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL BRILLIANT**

Measurements **8.01 X 5.74 X 3.65 MM**

GRADING RESULTS

Carat Weight **1.06 CARAT**

Color Grade **E**

Clarity Grade **VVS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG750539760**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG750539760
Report verification at igi.org

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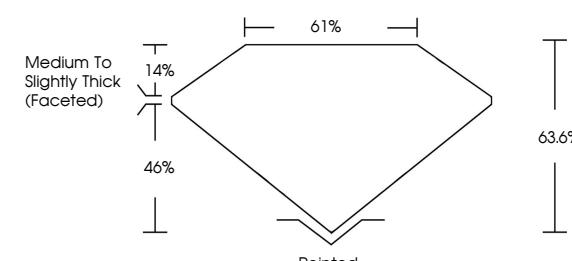
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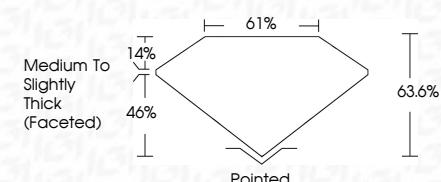
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PROPORTIONS



Sample Image Used



COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

FL	IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
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Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
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OVAL BRILLIANT

1.06 CARAT

E

VVS 2

63.6%

61%

Medium To Slightly Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

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